		Application No.	Applicant(s)	- iK
••	- C A II	09/985,730	YANNICK ET AL.	•
Notic	of Allowability	Examiner	Art Unit	
		Robert R. Raevis	2856	
All claims being allowable herewith (or previously mannerment of ALLOWABII	IG DATE of this communication appe , PROSECUTION ON THE MERITS IS ailed), a Notice of Allowance (PTOL-85) LITY IS NOT A GRANT OF PATENT RI on by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in to or other appropriate communication. This application is sufficient to the communication of the communication	his application. If not included ication will be mailed in due c	d ourse. THIS
1. This communicatio	n is responsive to <u>5-28-04</u> .			
2. Mail The allowed claim(s) is/are <u>11-46</u> .			
3. X The drawings filed	on <u>06 November 2001</u> are accepted by	the Examiner.		
a)	is made of a claim for foreign priority un Some* c) None of the: ed copies of the priority documents have a copies of the priority documents have of the certified copies of the priority documents documents have at the certified copies of the priority documents have at the certified copies of the priority documents have at the certified copies of the priority documents have at the priority documents have at the priority documents have at the priority documents	been received. been received in Application	No	on from the
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(a) ☐ including chan 1) ☐ hereto (b) ☐ including chan Paper No./Mai Identifying indicia such	WINGS (as "replacement sheets") must ges required by the Notice of Draftspers or 2) to Paper No./Mail Date ges required by the attached Examiner's Date as the application number (see 37 CFR 1 nt sheet(s) should be labeled as such in the	on's Patent Drawing Review of the control of the co	n the Office action of drawings in the front (not the l	back) of
	d/or INFORMATION about the depo s comment regarding REQUIREMENT			ote the
·	s Cited (PTO-892) n's Patent Drawing Review (PTO-948) ure Statements (PTO-1449 or PTO/SB/0	6. ☐ Interview Sur Paper No./M	ormal Patent Application (PTO nmary (PTO-413), lail Date .mendment/Comment	-152)
Paper No./Mail Dat			tatement of Reasons for Allov	vance
	HEZRON WILLIAMS SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800		RAEVIS AU2856	

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Art Unit: 2856

Allowabl Subject Matt r

As to claim 11, note was made of the combination of "*measuring* a temperature T1 of the drilling fluid at a well inlet, a temperature T2 at a bottom of the well, and a temperature T3 at a well outlet" (italics added, lines 8-10) with remaining claim limitations. The various measured temperatures at the various locations in Hansan (as illustrated in Figure 12) are not employed in the "method of *determining* a thermal profile of a drilling fluid" (italics added, lines 1-2 of claim 11) as called for in claim 11. The measured temperatures of Hansan are applied to compare an actual temperature profile with the thermal profile that had been determined *independent* of the measurements.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Robert R. Raevis whose telephone number is 571-272-2204. The examiner can normally be reached on Monday to Friday from 7am to 4pm. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

/ HEZŘON WILLIAMS DEBVISORY PATENT EXAMINEI

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